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②國玄東華大學

課 網 Course Outline

| | • | Course of | | | | |
|---|---|---|-----------------------------|-----------------|-------|--|
| | 材料科學 | 與工程學系學 | :士班 | | | |
| 中文課程名稱 Course Name in Chinese | n 材料基礎實驗(三):微電子製程 | | | | | |
| 英文課程名稱 Course Name in English | Fundamental Experime Microelectronics | ents in Materi | als (III) | : Processing in | ı | |
| 科目代碼 Course Code | MS_30800 | 班 別 Degree | 學士班 Bachelor's | | | |
| 修別 Type | 學程 Program | 學分數 Credit(s) | 2. 0 | 時 數 Hour(s) | 4.0 | |
| 先修課程 Prerequisite | 無 | | | | | |
| | Cour | 課程目標 se Objectives | | | | |
| 礎認識與實際操作經 The goal of the co practical experier | ·系同學對台灣蓬勃發展的 ·驗,做未來進入就業的準 ourse is to train stude ace in microelectronic stry in preparation fo | d備。 ents to gain a processes req or their future | basic under uired by Tai | estanding and | | |
| | | 系教育目標 lucation Objec [.] | tives | | | |
| 算定理論基礎 Set the theore | tical foundation | | | | | |
| 2 訓練實用技能 Train the prac | 訓練實用技能 Train the practical skill | | | | | |
| 3 培養優質人格 Form the posit | 培養優質人格 Form the positive cher | | | | | |
| 4 <u> </u> | 啟發創新思 Promote creative thinking | | | | | |
| 5 開展國際視野 Develop global | vision | | | | | |
| | 2. 亩业从 L | | | 課程目標與 力相關性 | 具系專業能 | |

素專業能力課程目標與系專業能力相關性
Correlation
between Course
Objectives and
Dept.'s Education
ObjectivesA Acquire required basic physical, chemical, and mathematic
knowledge for materials science and engineering.○

| В | 具備材料科學的專業知識,並能應用於解決工程上之問題。 Acquire required professional knowledge for materials science and engineering, applicable in solving engineering problems. | | | | |
|--|--|---|--|--|--|
| С | 具備邏輯思考、實驗執行、報告撰寫與數據解釋之能力。 Equipped with capabilities of logic thinking, execution of experiment, and data interpretation. | • | | | |
| D | 具備專業道德及責任感,與良好的溝通及團隊合作的能力。 Acquire professional morality and responsibility, and capability of quality communication and team cooperation | 0 | | | |
| Е | 具備適當的英文能力,應用於學習與交流。 Acquire English capability used for learning and interaction | 0 | | | |
| 圖示說明Illustration : ● 高度相關 Highly correlated ○中度相關 Moderately correlated | | | | | |
| 課程大綱 Course Outline | | | | | |
| 實驗內容包括無塵室的種類與要求、矽晶圓的切割與清洗、熱氧化實驗、CVD設備介紹與操作、濺鍍設備介紹與操作、光罩曝光與蝕刻實驗、TEOS沈積SiO2薄膜實驗、薄膜性質分析實驗:膜厚與基礎電特性等。 | | | | | |
| The experiments include types and requirements of clean room, cutting and cleaning of silicon wafers, thermal oxidation experiment, introduction and operation of CVD equipment, introduction and operation of sputtering equipment, photomask exposure and etching experiment, TEOS deposited SiO2 thin film experiment, thin film property analysis experiment: film thickness and basic electrical properties, etc. | | | | | |
| 資源需求評估(師資專長之聘任、儀器設備的配合···等) Resources Required (e.g. qualifications and expertise, instrument and equipment, etc.) | | | | | |
| 本所師資 Teachers of MSE department. | | | | | |
| 課程要求和教學方式之建議 Course Requirements and Suggested Teaching Methods | | | | | |
| 課堂實習為主、原理講授為輔。 Experiments supplemented by lectures on principles | | | | | |

其他 Miscellaneous